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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1253

Applicant: Xinye Liu

Application No.: 10/791,030

Filed: March 1, 2004

Examiner: Fuller, Eric B.

Art Unit: 1762

Docket No.: 40004551-0011-002

Title: Methods and Apparatus for Cycle Time Improvements for Atomic Layer Deposition

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on January 10, 2006
Date of Deposit

Jennifer L. Stewart
Name of Person Mailing Correspondence

Jennifer L. Stewart 1/10/06
Signature Date

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Sir:

In accordance with 37 C.F.R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a three (3) month extension of time, extending the period for response to February 4, 2006 from the Notice of Non-Compliant Amendment dated October 4, 2005. The Petition filing fee of \$1020.00 and an Amendment and Response to the Notice of Non-Compliant Amendment are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge Deposit Account No. 19-3140. An extra copy of this sheet is enclosed for deposit account charging purposes.

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Date: January 10, 2006

Respectfully submitted,

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